

PATENT APPLICATION
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q88662

Takenori OSADA, et al.

Appln. No.: 10/540,513

Group Art Unit: 2826

Confirmation No.: 6641

Examiner: Eduardo A. Rodela

Filed: June 23, 2005

For: COMPOUND SEMICONDUCTOR EPITAXIAL SUBSTRATE AND METHOD FOR
MANUFACTURING THE SAME

RESPONSE TO RESTRICTION REQUIREMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450


Sir:

In response to the Restriction Requirement, dated March 28, 2006, Applicant elects Group I, Claims 1-3, drawn to a compound epitaxial semiconductor substrate, for examination. This election is made without traverse.

Applicant reserves the right to file a Divisional Application directed to non-elected Claims 4-5.

Respectfully submitted,

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Date: April 28, 2006